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01-SM5-313
(ATI-0016)

JAN 17 2007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| | | |
|--------------------------|---|------------------------------|
| Applicant: |) | Group Art Unit: 1746 |
| |) | |
| Waldfried <i>et al.</i> |) | Confirmation No.: 3384 |
| |) | |
| Serial No.: 10/065,861 |) | Examiner: Markoff, Alexander |
| |) | |
| Filed: November 26, 2002 |) | Docket No.: ATI-0016 |

For: DRYING PROCESS FOR LOW-K DIELECTRIC FILMS

VIA FACSIMILE: (571) 273-8300
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT F

Sir:

This Amendment is submitted in response to the Final Office Action dated November 17, 2006. Please amend the Application as follows:

Do Not
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